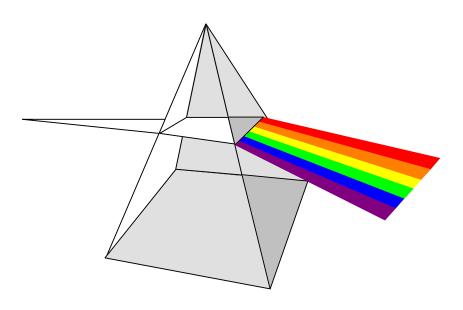


## **New Developments for MCS 500**





New Basic Developments recently introduced

- MCS 511 NIR Family
- OMK 500 H NIR
- Film Control Low Cost Thickness Measurement System
- Measuring Head for Low Reflection Coating 10°/10°



# New Software Developments soon available

- MCS 500 Driver for GRAMS® Software Package
- Driver to run cascaded MCS501/551 in Double Beam Mode



**Recently finished and current Projects** 

#### On-Line Measurement of Low-reflection Coatings on CRT

Company LEYBOLD Installations in Wales(finished) and Japan(Nov. 98)

In-Line Measurement of vacuum-coated foils

Company LEYBOLD Installation in Switzerland (Nov. 98)

#### • In-Line Measurement and Quality Control of coated Glass

Company LEYBOLD Installation in France (Oct. 98)



**Recently finished and current Projects** 

- Colour Measurement of PE-Coating on Photo Paper Company FUJI Netherlands 10/98
- Aromatics in Water
   Company DOW/PSL Netherlands/Germany
- Measurement of Fat, Protein, Moisture in Meat Company Reichert/Schnell GmbH 10/98



**Recently finished and current Projects** 

- On-Line Control of Production of "Bio-Diesel" / NIR LUT Germany 11 / 98
- Reflection of Lamp Bulbs ( 380 1700 nm)
   Auer GmbH / Germany 9/98
- In-Line Measurement of sugar and alcohol in filling plants
   Diessel Germany Test



#### **Spectrometer System MCS 511 NIR**



MCS 511 NIR with OMK500

- Polychromator MMS NIR
- 950 1700 nm (6nm/diode)
- 1400 2200 nm ( in Prep.)
- 1000 2400 nm ( in Prep.)
- Compatible with MCS500
   Familiy
- Cascadeablewith all MCS500



## Spectrometer System MCS 511 NIR

Wavelength range	950 - 1700 nm (InGaAs, cooled) 1400 - 2200 nm (ext. InGaAs, cooled) 1000 - 2400 nm (ext. InGaAs, cooled)
Wavelength accuracy	< 0,6 nm
Wavelength Reprod.	< 0,1 nm
Resolution	6 nm/ diode ( 18 nm acc. Rayleigh)
Absorption Range	0 3 AU
Linear Range	02 AU (With Blocking Filter RG1000)
Stray Light	< 0,1 %T measured at water band with blocking filter (RG850)
Noise	< 1 mAU (1sec. Measurement Time)



## Spectrometer System MCS 511 NIR

AD-Converter	15/16 bit
Interface	RS 422 ( serial, 20 Mbit/sec)
Transfer distance	Appr. 80 m ( Standard) Appr. 2500 m ( Fiber cable)
Housing	19" Standard incl Lamp 19" Protective housing IP65 19" Plug-in Rack 9,5" Housing ( without lamp)



**Applications of MCS 511 NIR** 

Food Industry

**Glass Industry** 

Forage Research

Pharmacie





Spectrometer System MCS 511 NIR Software

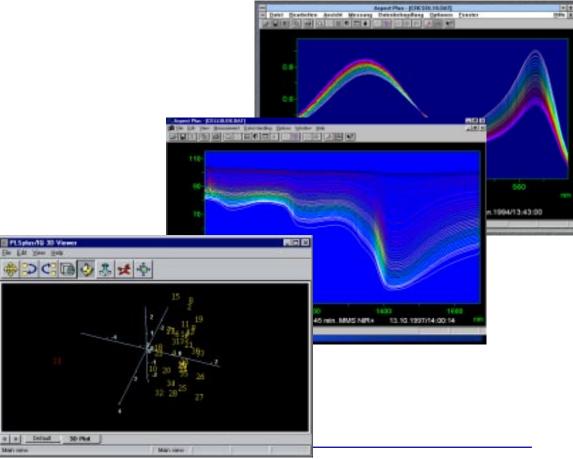
ASPECT PLUS

Customer-tailored Software

GRAMS<sup>®</sup> 32

LabView Library

C - Library





#### **Spectrometer System MCS 511 NIR**

**Integrating Spheres** 

**Reflection Head OMK 500** 

**Diffuse Reflection Probes** 

Optical Multiplexer (2..16 channels)

#### Accessories





#### **Spectrometer System MCS 511 NIR**

SMA Optics

Cell Holder

**Immersion Probes** 





**Spectrometer System MCS 511 NIR** 

**Reflection Head OMK 500 NIR** 

Wavelength Range Geometrie Light Source Life Timeof lamp Power Source

Fiber Connector

400 - 2400 nm 0°/45°(circular) Tungsten lamp > 5000 h 5 V/2A

ZEISS





#### **Measurement System for Low-Reflection Coatings**



Optimized for CRT

Geometrie 10°/10°

High Attenuation of back Reflection

Automatic version with integrated Calibration Set available



## **Reflection Handy Head 10°/10°**

Measurement of low reflect on glass surfaces	ting coatings
10° / 10 <b>°</b>	
360 - 2000 nm	
2 mm	
2 x ZEISS	200
	on glass surfaces 10° / 10° 360 - 2000 nm 2 mm



#### Film Control - Thickness Measurement System



Single Layer Coatings

Range 1 - 30 um

FFT Algorithm

Integrated PC

**Tungsten Light Source** 



#### **Film Control - Thickness Measurement**

#### Thickness Range

Principle Polychromator Light Source Electronic unit

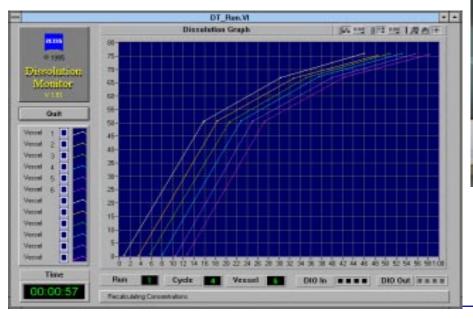
Accessories

1 - 30 um (optical thickness)
Single Layer
White light interference
MMS1
Tungsten, 5V/8W
Integrated PC
14-bit electronic unit
Y - Light guide
SMA Optic



#### MultiChannel Dissolution System ZDIS-MUX

MCS 551UV / CLD500 8-Channel MUX Immersion Probes





LabView<sup>®</sup> based Software